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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Eiichi ISHII et al.

Serial No. 10/659,327

Filed September 11, 2003

METHOD OF SURFACE TREATMENT

OF TITANIUM METAL

: Mail Stop: ISSUE FEE

Confirmation No. 3781

[Group Art Unit 1753

Examiner Harry Wilkins, III]

Attorney Docket No. 2003 1290

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEE FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975.

Applicants are submitting herewith a copy of an Office Action issued October 19, 2004 in connection with the European application corresponding to the present U.S. application, and copies of the EP 0 305 241 reference (with English abstract) and the US 3,085,949 reference cited in the Office Action. [The GB 2 261 227 reference cited in the Office Action is already of record in the present U.S. application, having been cited in the IDS of September 11, 2003.] Under the provision of 37 CFR 1.97(i), it is requested that the instant IDS and attachments be placed in the file for the present application.

Respectfully submitted,

Eiichi ISHII et al.

Бу: ॄ

Hael R. Davis

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